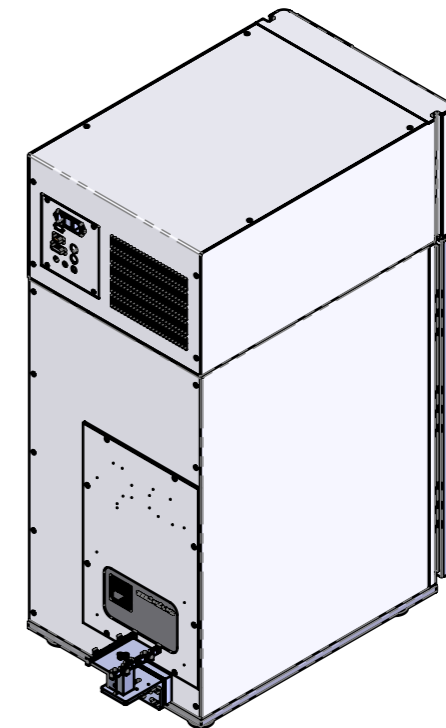
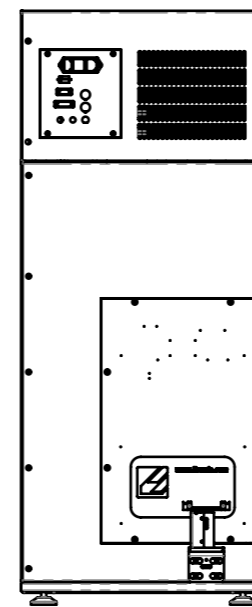
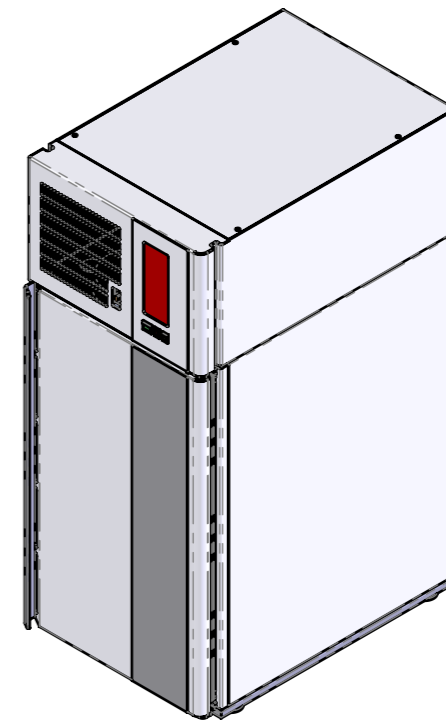


x Position varies depending on handling adjustment within chamber



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Material		Name	Datum	Visum													
Oberfläche		Gez. Manser	08.08.2019	FMr													
Werkstückkanten	DIN ISO 13715 	Allgemeintoleranzen ISO 2768-mK	Geä. -	13.08.2019	Bezeichnung STX110-XXBT Mirrored Gate Location												
			<table border="1"> <tr> <td>0 ...6</td> <td>>6 ...30</td> <td>>30 ...120</td> <td>>120 ...400</td> <td>>400 ...1000</td> <td>>1000 ...2000</td> </tr> <tr> <td>± 0.1</td> <td>± 0.2</td> <td>± 0.3</td> <td>± 0.5</td> <td>± 0.8</td> <td>± 1.2</td> </tr> </table>	0 ...6		>6 ...30	>30 ...120	>120 ...400	>400 ...1000	>1000 ...2000	± 0.1	± 0.2	± 0.3	± 0.5	± 0.8	± 1.2	SN 210130 E
0 ...6	>6 ...30	>30 ...120	>120 ...400	>400 ...1000	>1000 ...2000												
± 0.1	± 0.2	± 0.3	± 0.5	± 0.8	± 1.2												
		Oberflächenrauheit	<table border="1"> <tr> <td>✓ Ra 3.2</td> <td>✓</td> </tr> </table>	✓ Ra 3.2	✓	Format A3	Änderungs Nr. - Blatt 1 von 1										
✓ Ra 3.2	✓																